



In re Application of

Docket No. 35.C11946 *3724*

AKIRA FUNAKOSHI, ET AL.

Application No.: 08/801,464

Examiner: C. Dexter

Filed: February 18, 1997

Group Art Unit: 3724

For: SUBSTRATE CUTTING METHOD
AND SUBSTRATE CUTTING
APPARATUS

Date: March 27, 2001

DIRECTOR, THE COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment and Petition for Extension of Time
in the above-identified application.

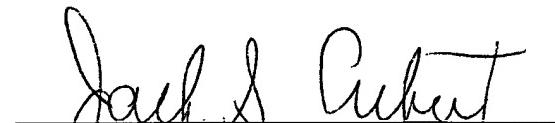
No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED					MAR 30 2001	
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	TECHNOLOGY CENTER R3700	RATE ADDITIONAL FEE
TOTAL CLAIMS	34	MINUS	34	= 0	x \$ 9 \$18	\$ 0.00
INDEP. CLAIMS	6	MINUS	6	= 0	x \$40 \$80	\$ 0.00
Fee for Multiple Dependent claims \$135°/\$270						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ 0.00

°Verified Statement claiming small entity status is enclosed, if not
filed previously.

- A check in the amount of \$_____ is enclosed.
- Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- Any prior general authorization to charge an issue fee under 37 C.F.R. § 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. §§ 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- A check in the amount of \$890.00 to cover the Extension fee for response within three (3) months is enclosed.
- A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.



Attorney for Applicants
Jack S. Cubert
Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

35.C11946



PATENT APPLICATION

X 19 D
and H. Kondo
H Chapman
4/20/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
AKIRA FUNAKOSHI, ET AL.) : Examiner: C. Dexter
Application No.: 08/801,464) : Group Art Unit: 3724
Filed: February 18, 1997) :
For: SUBSTRATE CUTTING METHOD) March 27, 2001
AND SUBSTRATE CUTTING APPARATUS) :
RECEIVED

Director, the Commissioner for Patents
Washington, D.C. 20231

MAR 30 2001
TECHNOLOGY CENTER R3700

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition the Commissioner of Patents to extend the time for response to the Office Action dated September 27, 2000 from December 27, 2000 up to and including March 27, 2001. A check in the amount of \$890.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

The Examiner is respectfully requested to amend the above-identified application as follows:

03/28/2001 BHABTEW 00000116 08801464

01 FC:117

890.00 OP